

Summary: Contactless product transport

*Publications:*

J. van Rij, J. Wesselingh, R.A.J. van Ostayen, J.W. Spronck, R.H. Munnig Schmidt, J. van Eijk, *Planar wafer transport and positioning on an air film using a viscous traction principle*, Tribology International 42 (p. 1542 – 1549), 2009

J. van Rij, J. Wesselingh, R.A.J. van Ostayen, J.W. Spronck, R.H. Munnig Schmidt, J. van Eijk, *Planar Flat Product Transport Using Viscous Traction*, Proceedings of the STLE/ASME International Joint Tribology Conference IJTC2008, October 20-22, Miami, Florida, USA, Paper IJTC2008-71153

Wesselingh, J., Ostayen, R.A.J. van, Spronck, J.W., Munnig Schmidt, R.H. & Eijk, J. van: *Actuator for contactless transport and positioning of large flat substrates*. In: 10th anniversary international conference of the european society for precision engineering and nanotechnology (pp. 145-149), Bedford: Euspen Headquarters, 2008

Wesselingh, J., Spronck, J.W., Ostayen, R.A.J. van, Munnig Schmidt, R.H. & Eijk, J. van: *Contactless positioning using a thin air film*. In: *9th international conference of the european society for precision engineering and nanotechnology: san sebastian, spain* (pp. 324-328), 2009

*Contact:*

Ron van Ostayen

r.a.j.vanOstayen@tudelft.nl

telefoon (015) 278 16 47